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SERIAL NUMBER 10/668,186	FILING OR 371(c) DATE 09/24/2003 RULE	CLASS 257	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 1248-0673P
APPLICANTS Yutaka Takafuji, Nara-shi, JAPAN; Takashi Itoga, Nara-shi, JAPAN; <i>Lee</i>				
** CONTINUING DATA ***** <i>Lee</i>				
** FOREIGN APPLICATIONS ***** <i>Lee</i> JAPAN 2002-280078 09/25/2002 JAPAN 2002-299577 10/11/2002 JAPAN 2003-067109 03/12/2003				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/20/2003				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <i>[Signature]</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 17	TOTAL CLAIMS 56
INDEPENDENT CLAIMS 14				
ADDRESS 2292				
TITLE Single-crystal silicon substrate, SOI substrate, semiconductor device, display device, and manufacturing method of semiconductor device				
FILING FEE RECEIVED 2372	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	